



Docket No: 740756-1638

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Hisashi OHTANI et al. )  
Serial No. 08/807,737 ) Art Unit: 2829  
Filed: February 27, 1997 ) Examiner: Evan Pert  
For: METHOD FOR MANUFACTURING ) Confirmation No. 5408  
SEMICONDUCTOR DEVICE )

CORRECTION TO PRIOR INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
220 20<sup>th</sup> Street S.  
Customer Window, Mail Stop DD  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, Virginia 22202

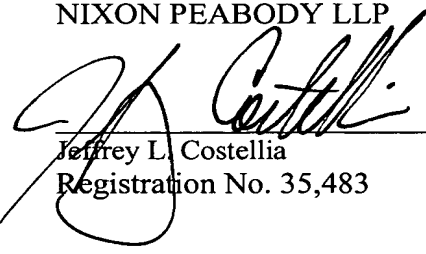
Sir:

Further to our Correction to Prior Information Disclosure Statement filed on March 1, 2004, Applicants have identified a typographical error in the text of request, namely, the date of the publication of Yunosuke KAWAZU et al., which was corrected to 12/1990, was incorrectly noted in the text of the correction as 10/20/1999, rather than 10/20/1990 as originally provided. Since the attached corrected PTO-1449 was correct, no further action by the Examiner is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380 (740756-1638).

Respectfully submitted,

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